

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): NAITO et al.

Application No.: 10/006,135

Filed: December 10, 2001

Title: MANUFACTURING METHOD OF
SILICON CARBIDE SINGLE
CRYSTALS

Attorney Docket No.: 01-235

Group Art Unit: 1765

Examiner: ANDERSON, Matthew A

April 14, 2003

CERTIFICATE OF HAND DELIVERY

I hereby certify that this correspondence is being hand delivered to and deposited with the USPTO at the Customer Service Window, Office of Initial Patent Examination, Crystal Plaza Building 2, Room 1B03, 2011 South Clark Place, Arlington, VA 22202 on April 14, 2003.

Typed Name: DAVID G. POSZ

Signature: 

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

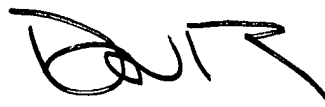
Sir:

In response to a Restriction/Election requirement mailed on March 17, 2003 in connection with the above application, Applicant hereby elects the claims in Invention II (claims 24 – 29, drawn to substrate) without traverse.

Examination of the present application in view of the above election is respectfully requested.

Please charge any necessary fees to Deposit Account 50-1147.

Respectfully submitted,



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